

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Shinichi Kurita et al.  
Serial No. : 10/782,503  
Filed : February 19, 2004  
For : METHODS AND APPARATUS FOR DETERMINING A  
POSITION OF A SUBSTRATE RELATIVE TO A  
SUPPORT STAGE  
Examiner : Emily Y. Chan  
Group Art Unit : 2829  
Customer No. : 41161  
Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

In response to the Examiner's Office Action dated  
March 26, 2007, applicants amend the above-identified  
application as follows:

**Listing of the Claims** begins on page 2.

**Remarks** begin on page 9.